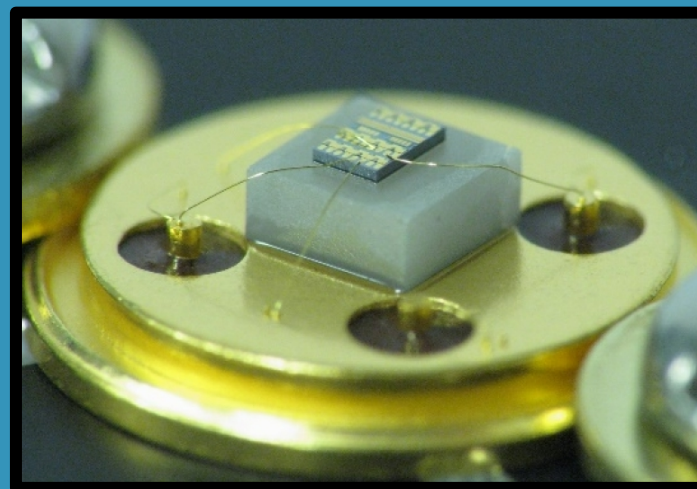


Enhancing Semiconductor Laser Performance Using 3D-Printed Microlenses

Eric Murillo

D. K. Serkland, B. Kaehr, M. A. Gallegos, G. M. Peake,
M. G. Wood, A. J. Grine, T. J. Morin, C. R. Tait, K. M.
Geib

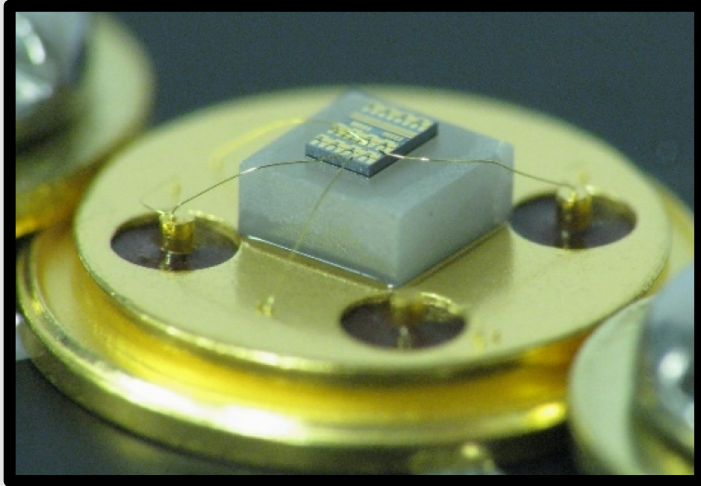


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Motivatio

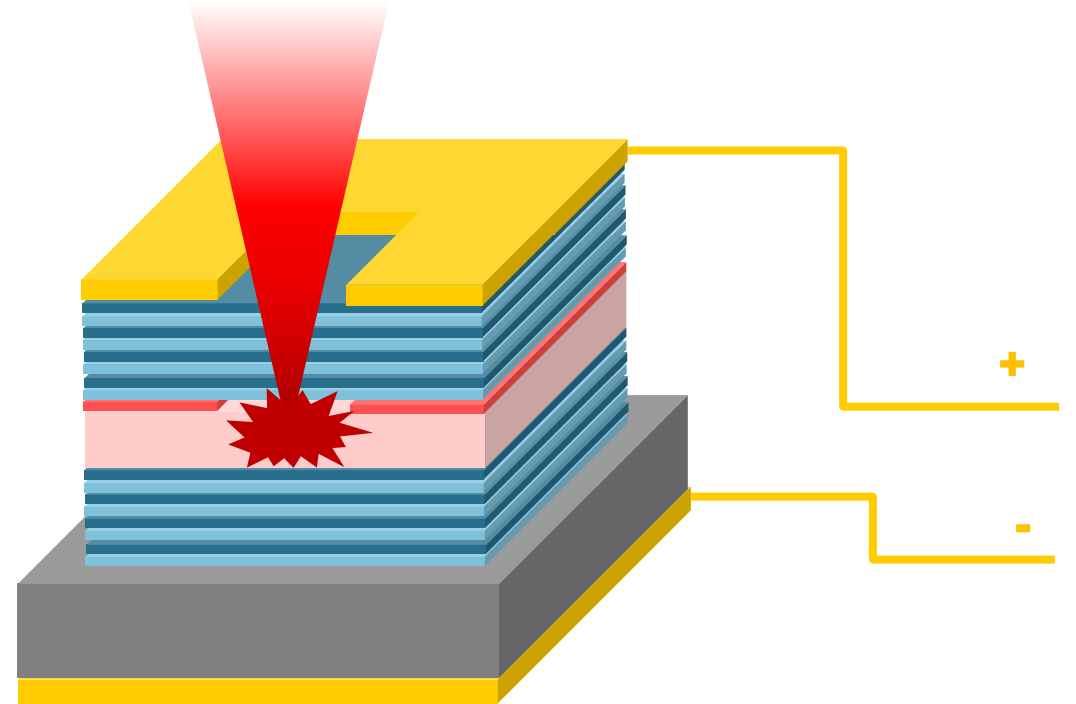
Improve performance of Vertical-Cavity Surface-Emitting Lasers (VCSELs)



What is a VCSEL?

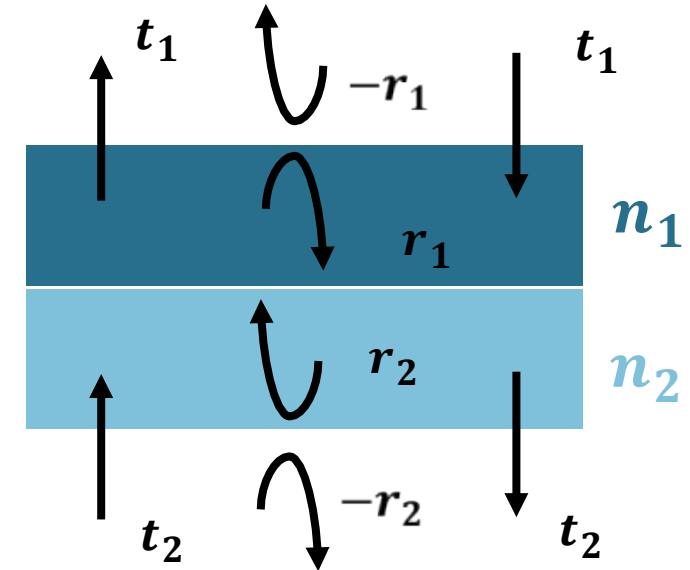
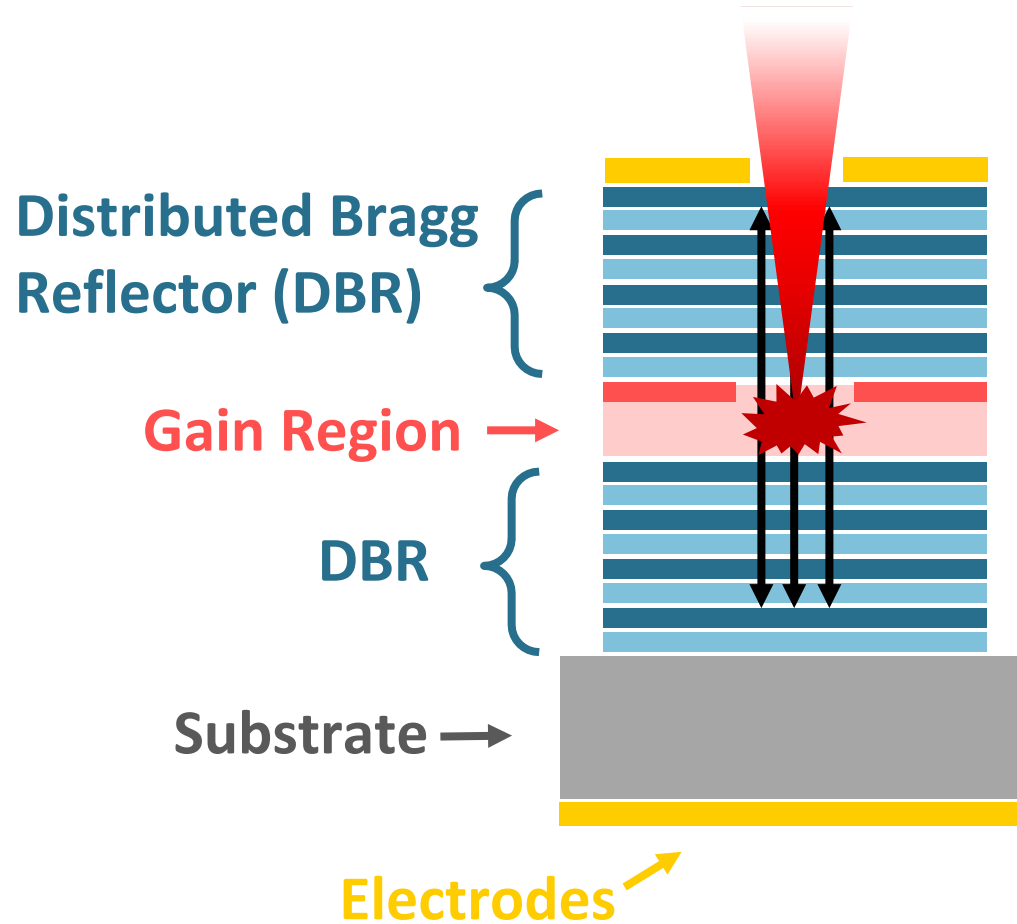
Semiconductor laser

- Small size (μm)
- Easily fabricated
- Low threshold current (1mA)
- Round beam shape
- Low output power (<2mW)
- Frequency noise (>20MHz)



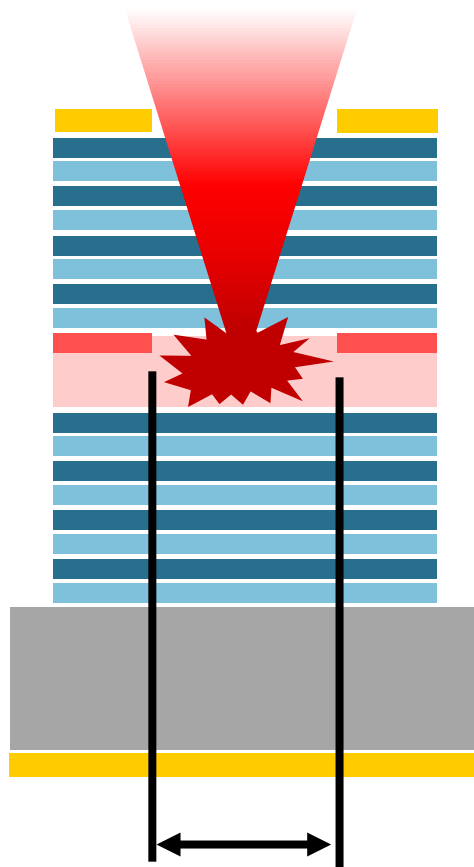
How does it

work?
Light oscillates in the cavity causing the active region to lase

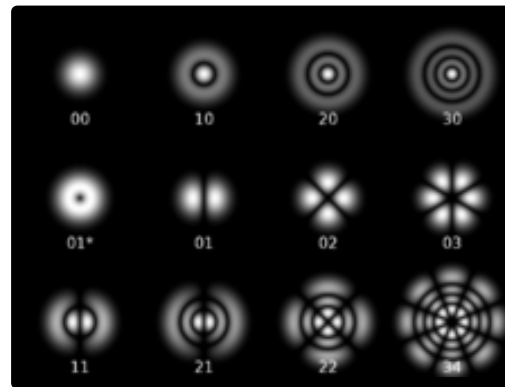


Improve Output

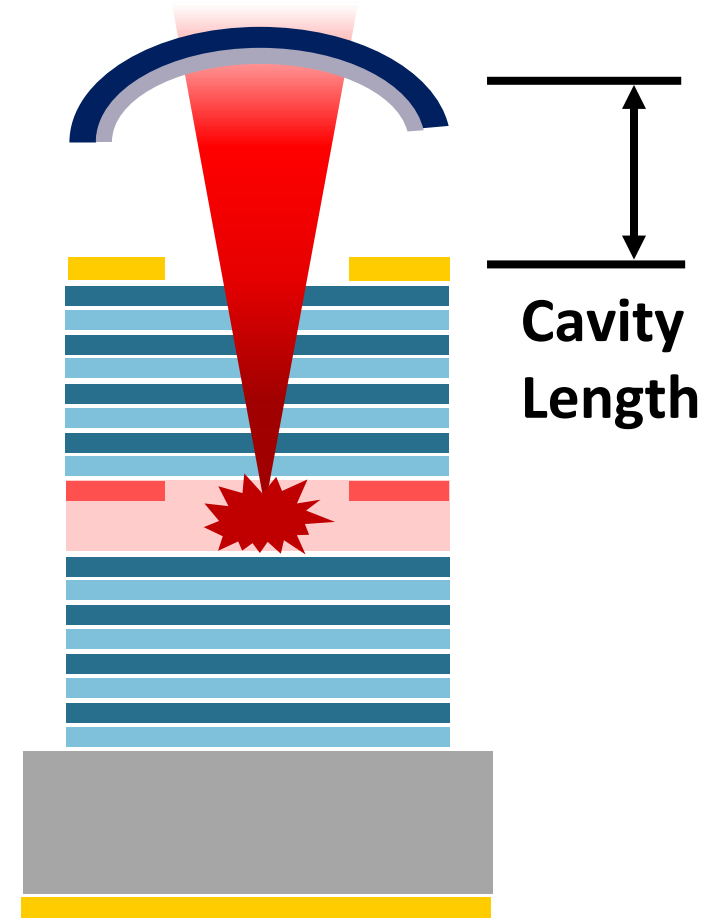
Power
Exceed 2mW limit without sacrificing beam shape or linewidth



Increase
Area



Beam
Profiles



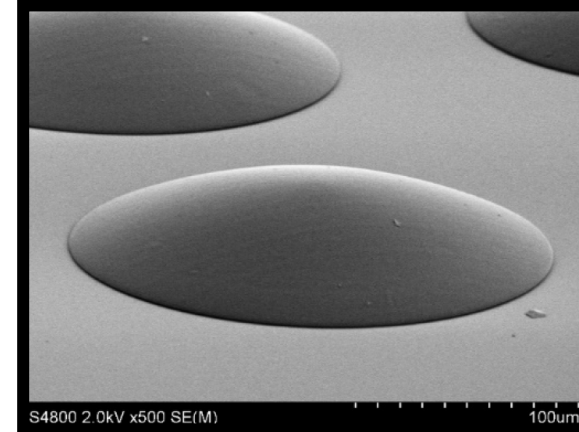
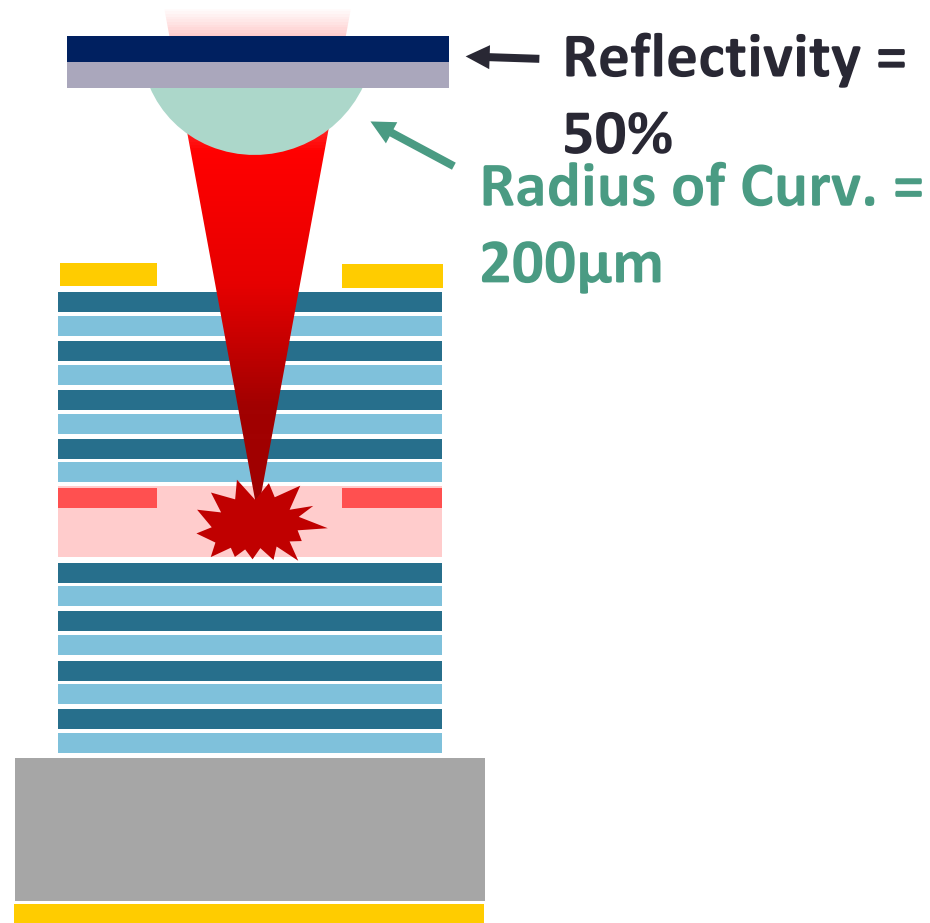
Cavity
Length

External
Cavity

3D Microlenses as External

Reflectors

3D microlenses simplify testing process

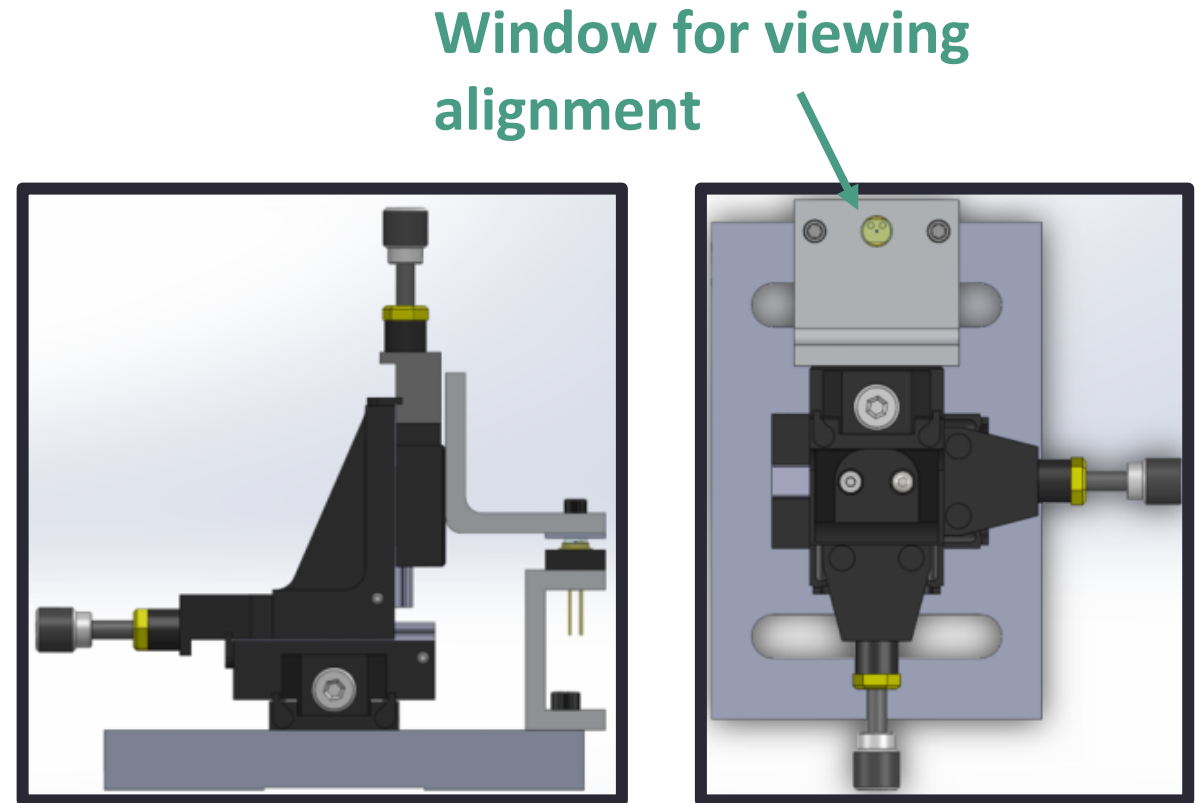
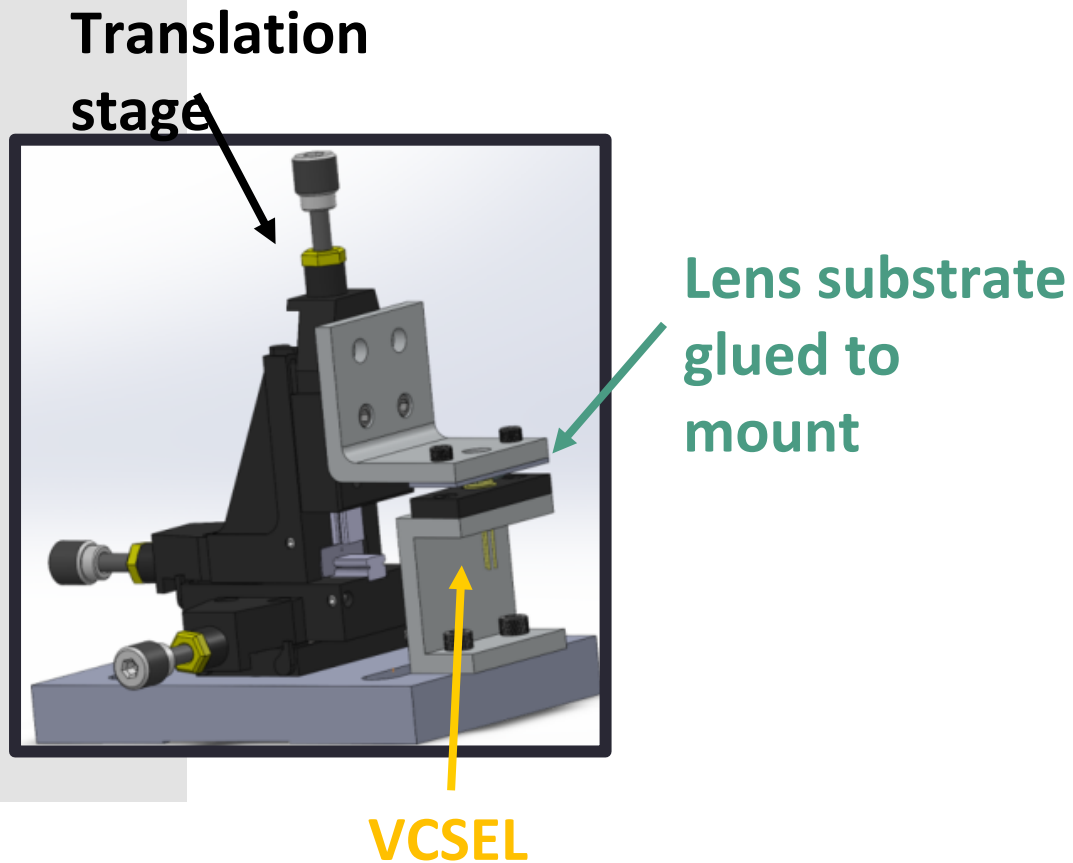


SEM of 3D-Printed
Microlens

Accuracy: $< 0.2\mu\text{m}$

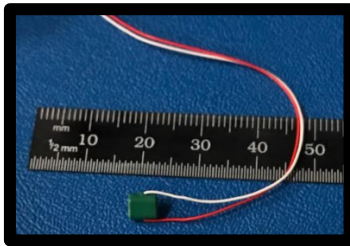
Experimental Design

Mounting microlenses on translation stage above VCSEL

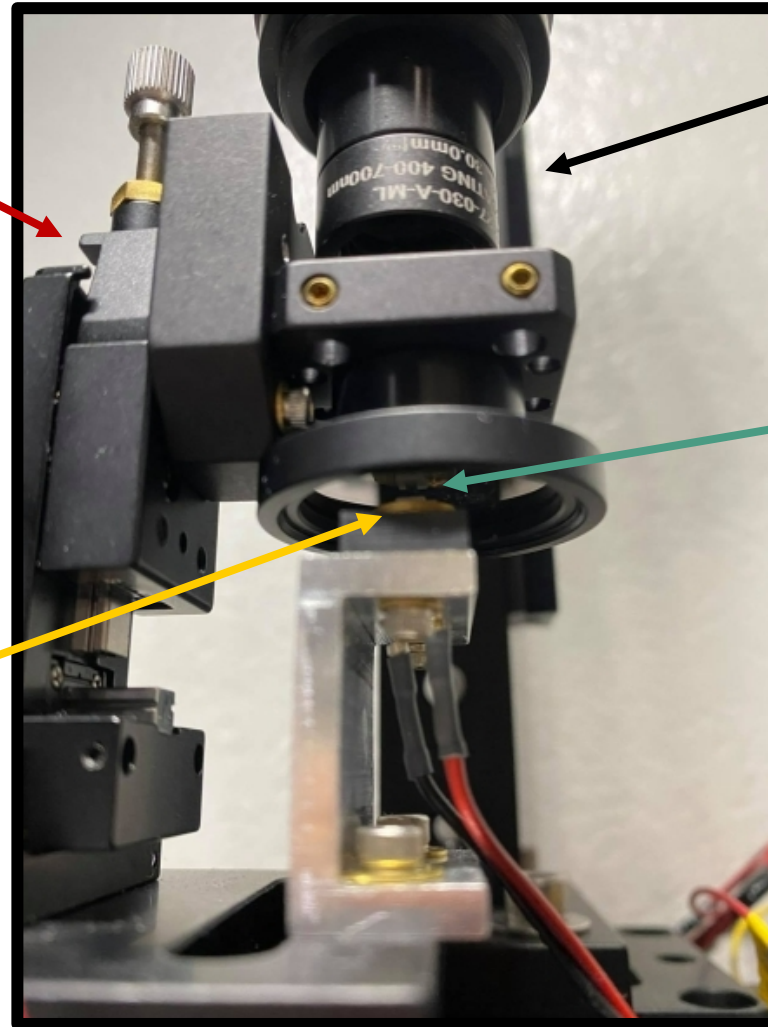
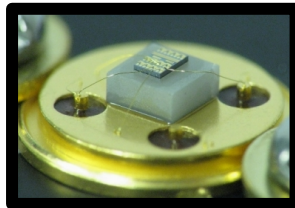


Design Setup

Piezo

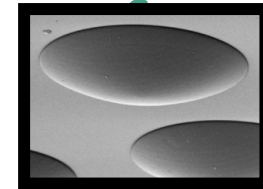


VCSEL



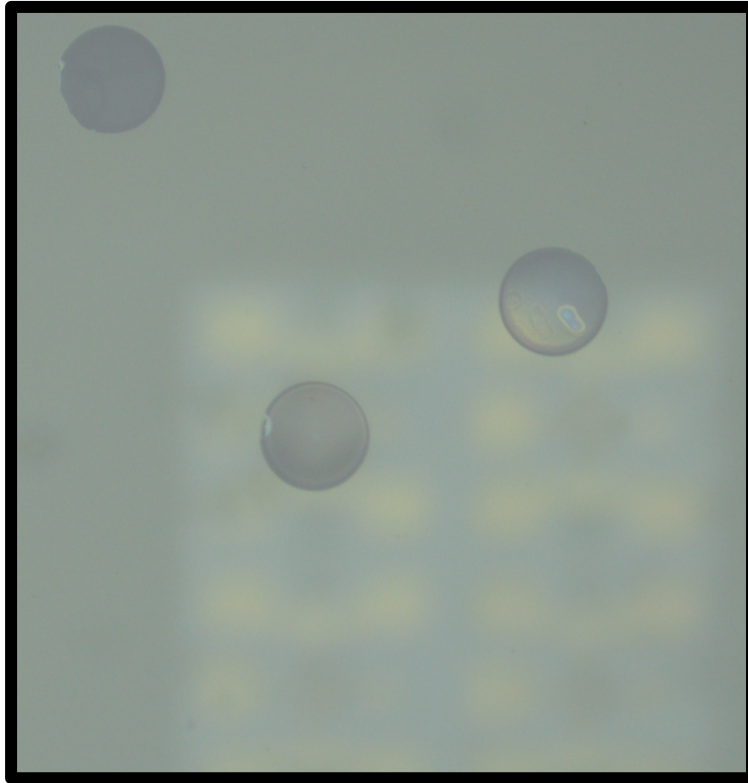
Microscope

Mounted microlens

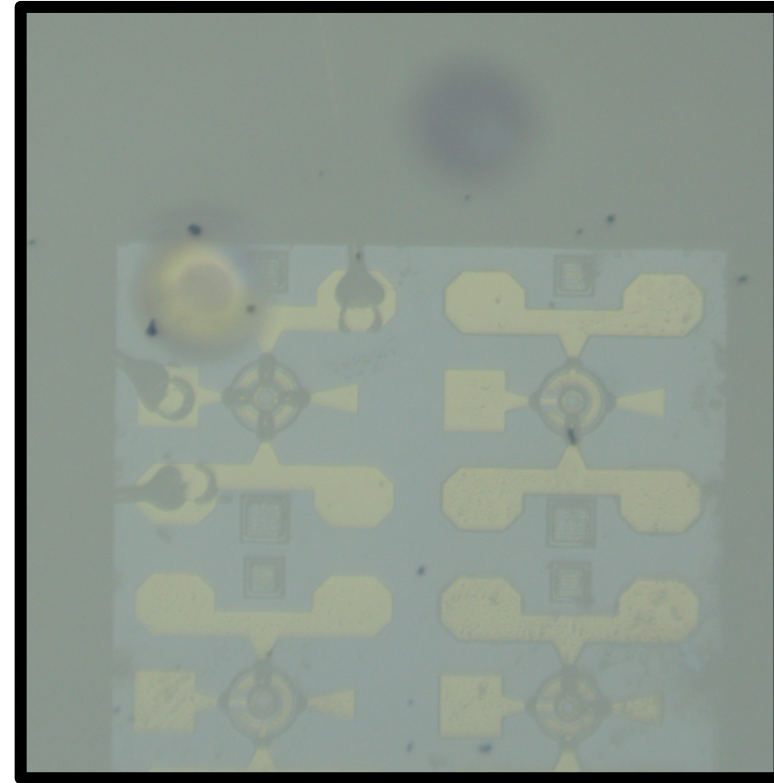


Experimental Execution

3D microlens positioned above lasing VCSEL



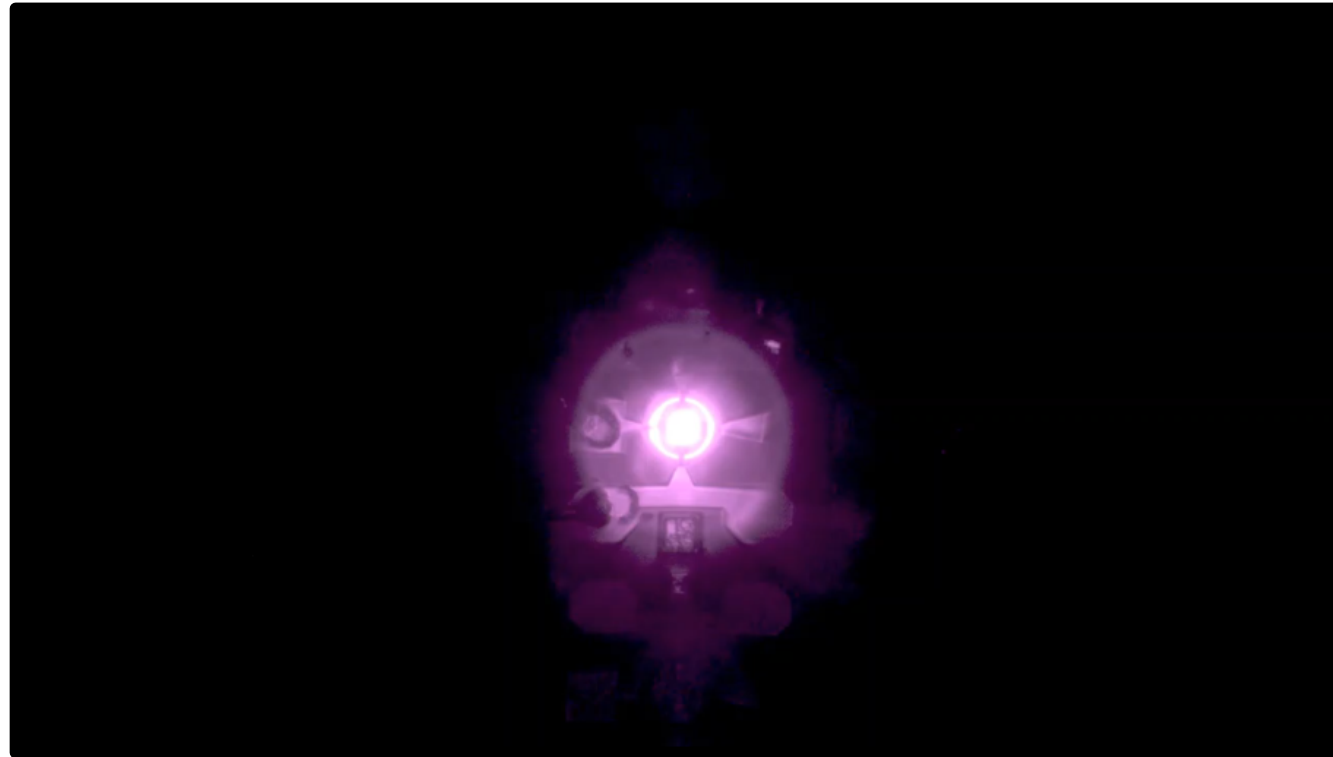
Microlenses in Focus



VCSELs in Focus

Experimental Execution

3D microlens positioned above lasing VCSEL



Aligning lens with VCSEL and adjusting height drastically improves output power

Reference

S Literature

D. K. Serkland, M. T. Murillo, B. Kaehr, M. A. Gallegos, G. M. Peake, M. G. Wood, A. J. Grine, T. J. Morin, C. R. Tait, K. M. Geib, “Transverse mode control of VCSELs using 3D-printed micro-optics,” submitted on 8/26/2020 to the Vertical-Cavity Surface-Emitting Lasers Conference at the SPIE Photonics West Conference (scheduled for March 2021).

Sourced Images

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<https://nypost.com/2020/02/03/russian-satellite-appears-to-be-stalking-us-satellite/>

Acknowledgements

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